

PATENT

Docket No.: JCLA4539-CA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: DAVID LIN)
Filed: HEREWITH)
For: METHOD FOR PROCESSING A FILM)
Examiner: MAYES, M)
Group Unite: 1734)



INFORMATION DISCLOSURE STATEMENT

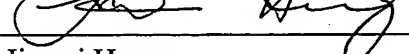
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Enclosed is form PTO-1449 listing 13 reference(s) that are also enclosed. This Information Disclosure Statement is being filed with this application, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1).

Respectfully submitted,

Dated: 2/25/2002

By: 
Jiawei Huang
Registration No. 43,330

Correspondence Address:
4 Venture, Suite 250
Irvine, California 92618
(949) 660-0761